Total Humber of T	Il correspondence after initial Pages in This Submission		First Named Inventor Art Unit Examiner Name Attorney Docket Number LOSURES (Check all		1	02/11/2004 Jaiprakash, et al. 2186 TBA 112020.143US2 NAN-19
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Firm Name Signature Printed name Date	SIGNA Wilmer Cutler Picker	ring Hale	M. Dichiara	Reg. No.	R AGI	38,005

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jaiprakash et al.

Application No.:

10/776,059

Examiner: Unknown

Filed:

February 11, 2004

Group Art Unit: 2186

For:

Devices Having Horizontally-Disposed Nanofabric Articles and Methods

of Making the Same

Atty. Docket No.:

112020.143 US2 (NAN-19)

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on January 3, 2005.

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Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicants and their legal representatives hereby make of record on the attached Form PTO-1449 the following publications which are known to them and considered warranting disclosure under 37 C.F.R. §1.56 and 1.97-98.

Copies of the publications listed on the attached Form PTO-1449, with the exception of the cited U.S. Patents and the U.S. published applications, are submitted herewith. It is respectfully requested that the Examiner initial and return a copy of the subject Form PTO-1449 with the next Patent Office communication.

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Jaiprakash et al.

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The submission of these publications does not constitute a representation by the

Applicants that a search has been made or that no better art exists and does not constitute an

admission that the listed publications are material or constitute "prior art." Applicants reserve

the right to take appropriate action to establish the patentability of the disclosed invention over

the listed publications, should one or more of the publications be applied against the claims of

the present application.

It is Applicants' belief that the Information Disclosure Statement is being filed prior to

the mailing date of the first Office Action on the merits and, therefore, no fee is due. However,

in the event a fee is due, please charge any fee deficiency or credit any overpayment to Deposit

Account No. 08-0219.

Respectfully submitted,

Dated: January 3, 2005

Peter M. Dichiara

Registration No. 38,005

Attorney for Applicants

Wilmer Cutler Pickering Hale and Dorr LLP

60 State Street

Boston, Massachusetts 02109

Tel: (617) 526-6466 Fax: (617) 526-5000

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JAN 0 6 200STATEMENT BY APPLICANT	First Named Inventor	Jaiprakash et al.	
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	Examiner Name	TBA	
of 4	Attorney Docket Number	112020.143US2 NAN-19	

Examiner	Cite	Document Number	S. PATENT DOCUI	Name of Patentee or Applicant	Pages, Columns, Lines,
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Application Number	10/776,059			
Filing Date	02-11-2004			
First Named Inventor	Jaiprakash et al.			
Art Unit	2186			
Examiner Name	TBA			
Attorney Docket Number	112020.143US2 NAN-19			

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(Use as many sheets as necessary)	Art Unit	2186	
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